

Docket No.: 0042697.00149US3
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Roy G. GORDON et al. Confirmation No.: 7410
Application No.: 10/534,687 Art Unit: 1621
Filed: May 12, 2005 Examiner: G. P. Nazario
Title: ATOMIC LAYER DEPOSITION USING METAL AMIDINATES

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT (IDS)

Dear Sir:

This Supplemental Information Disclosure Statement is being filed after the mailing date of the first Office Action on the merits and before the mailing date of a final Office Action or a Notice of Allowance.

Please charge the \$180.00 fee to our Deposit Account No. 08-0219.

Applicants request that the Examiner initial and return a copy of the enclosed Form PTO SB-08 with the next communication.

Respectfully submitted,

Dated: December 12, 2008

/Yung-Hoon Ha/
Yung-Hoon Ha
Registration No.: 56,368
Agent for Applicant(s)

Wilmer Cutler Pickering Hale and Dorr LLP
60 State Street
Boston, Massachusetts 02109
(617) 526-6000 (telephone)
(617) 526-5000 (facsimile)